

<b>Notice of References Cited</b>	Application/Control No. 10/542,896		Applicant(s)/Patent Under Reexamination OKABE ET AL.	
	Examiner CYNTHIA LEE		Art Unit 1795	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0041292	11-2001	Hayashida et al.	429/218.2
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
*	N	JP 2002-256301	09-2002	JP	Okada	H01M 4/38
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	Q					
	R					
	S					
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#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	machine translation of JP 09-007591
	V	machine translation of 2002-309327
	W	machine translation of 2002-256301
	X	

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